



# ESI - PR3800 - FLUSH DIAPHRAGM PRESSURE SENSOR

PR3800EX02.5BG  
4-20mA, 0..2,5 bar, Tri-clover 1.5", DIN, Ex

- Thick film sensor technology for long service life
- Pressure ranges up to 400 bar
- Up to 250°C media temperature option
- Easy clean flush membrane to prevent clogging



### Product description

Robustly constructed from stainless steel, the PR3800 series incorporates the latest strain gauge technology together with a custom IC amplifier offering excellent stability and accuracy over a long service life. The range offers a stable and accurate output signal of 4-20 mA with options for 0-5 V and 0-10 V. Typical applications include food processing, pharmaceutical, petrochemical, waste water and slurry handling. In these installations the process media may corrode the sensing diaphragm or clog the narrow pressure inlet on a standard transmitter. The flush membrane can be easily cleaned for long term reliability and outstanding performance. For hygienic applications the PR3800 series provides a sanitary grade pressure fitting. Seals are available in a variety of forms and materials for a wide range of applications and can be directly attached to the proposed connection or remotely via stainless steel capillary. Pressure ranges available from 0-200 mbar to

An optional ATEX and IECEx approved versions of this range are available for explosion protection for flammable gases (zone 0), dusts (zone 20) and mining areas (group I M1).

### Specifications

Ambient temperature	-20..85°C
Approvals	CE, IEC
Atex Approvals	Ex II 1 D Ex ia IIIC T135 °C Da, Ex II 1 G Ex ia IIC T4 Ga, Ex I M 1 Ex ia I Ma
Atex approved	Yes
Electrical connection	DIN A 43650
EMC	EN61000-6-4, EN61000-6-2
Linearity	≤±0.3% BSFL
Materials Wetted Parts	Stainless steel
Media temperature	-20..85°C
Output	4-20 mA

<b>Overpressure protection</b>	3.75 bar
<b>Pressure Range Max</b>	2.5
<b>Pressure Range Min</b>	0
<b>Pressure reference</b>	Gauge
<b>Process connection</b>	Pipe clamp (tri-clover) 1.5"
<b>Sensor technology</b>	Ceramic thick film or Isolated Piezoresistive Silicon
<b>Storage temperature</b>	5..40°C
<b>Supply voltage</b>	13-36 V DC